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Patricia Muir

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi OKUMURA
Serial No.: 10/615,670
Filed: July 8, 2003
Title: **METHOD OF FORMING SEMICONDUCTOR THIN-FILM
AND LASER APPARATUS USED THEREFORE**
Examiner: Samuel M. Heinrich
Group Art Unit: 1725
Confirmation No.: 9827
Attorney Docket No.: 100806-00215 (NECA 20.494)

January 31, 2006

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

S I R :

In response to the Office Action mailed on August 1, 2005, please amend the above-captioned application as follows: